•	Application No.	Applicant(s)	Applicant(s)	
`	10/517 025	7,025 KAWANISHI ET AL.		
Notice of Allowability	10/517,025 Examiner	Art Unit		
			• .	
	Amy Hsu	2622		
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	6 (OR REMAINS) CLOSED in) or other appropriate comm RIGHTS. This application is to	n this application. If not included unication will be mailed in due c	d ourse. THIS	
1. \boxtimes This communication is responsive to <u>12/7/2004</u> .				
2. ⊠ The allowed claim(s) is/are <u>1-15</u> .		- 4		
3. ☑ Acknowledgment is made of a claim for foreign priority u a) ☑ All b) ☐ Some* c) ☐ None of the:		or (f).		
1. 🖂 Certified copies of the priority documents hav		A.I		
2. Certified copies of the priority documents hav	, ,		6 41	
3. Copies of the certified copies of the priority do	ocuments have been receive	d in this national stage application	on from the	
International Bureau (PCT Rule 17.2(a)).				
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDON! THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the requ	uirements	
4. A SUBSTITUTE OATH OR DECLARATION must be subn INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.			
(a) I including changes required by the Notice of Draftsper	son's Patent Drawing Review	w (PTO-948) attached		
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date	_,			
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date	's Amendment / Comment o	r in the Office action of		
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			back) of	
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 	osit of BIOLOGICAL MAT FOR THE DEPOSIT OF BIO	ERIAL must be submitted. No OLOGICAL MATERIAL.	ote the	
		•		
Attack mant/a)		•		
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. Notice of In	formal Patent Application		
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)		ummary (PTO-413),		
3. ⊠ Information Disclosure Statements (PTO/SB/08),	Paper No.	/Mail Date Amendment/Comment		
Paper No./Mail Date 12/7/2004 4. Examiner's Comment Regarding Requirement for Deposit	8. ⊠ Fxaminer's	Statement of Reasons for Allow	vance	
of Biological Material		The state of the s		
	9. 🔲 Other			
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	SU	LIN YE PERVISORY PATENT EXAM	IINER	

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Specification

1. The abstract of the disclosure is objected to because it is not a single paragraph within the range of 50 to 150 words. Correction is required. See MPEP § 608.01(b).

Allowable Subject Matter

- 1. Claims 1-15 are allowed.
- 2. The following is an examiner's statement of reasons for allowance: The prior art references cited disclose an electronic camera with smear detection and reducing apparatus, where the method of reducing smear involves reading photometry information under certain exposure values and then changing the exposure values such as shutter speed and aperture and taking another photometry reading and subtracting this from the first photometry values to obtain smear amount. The prior art also teaches the apparatus with automatic gain control as a way to affect exposure amount. However, the prior art does not disclose measuring red, green, and blue information integral values rather than luminance information, in combination with a fixed gain but varying shutter speed and aperture value between the two readings in order to calculate a smear amount, further in combination with the other limitations of Claim 1.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Yoshinao (JP 2002-305689) teaches a camera which reduces smear by reading photometry (luminance) information and then changing exposure values and taking a second reading of luminance information and subtracting from the first value to obtain smear amount.

Kidono et al. (US 6618090) teaches an automatic exposure control apparatus where image capturing is performed at a double exposure time and a single exposure time.

Kidono et al. (US 7167204) teaches an automatic exposure control apparatus to prevent exposure errors resulting from smear.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Amy Hsu whose telephone number is 571-270-3012. The examiner can normally be reached on M-F 8am-5pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Lin Ye can be reached on 571-272-7372. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Amy Hsu Examiner Art Unit 2622

ARH 9/26/2007

LIN YE SUPERVISORY PATENT EXAMINER